



PATENT APPLICATION *FW*

Date July 17, 2007

In re the Application of

Sadayoshi HORII et al.

Group Art Unit: 1763

Application No.: 10/529,466

Examiner: R. BUEKER

Filed: March 29, 2005

Docket No.: 123373

For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE AND SUBSTRATE  
PROCESSING APPARATUS

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired April 17, 2007, an extension of time for a period of 3 months is hereby requested. Attached hereto is our Check No. 194921 in the amount of \$1020 in payment for:

- Extension fee for response within first month pursuant to §1.136(a) (\$120.00)  
 Extension fee for response within second month pursuant to §1.136(a) (\$450.00)  
 Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1020.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,

James A. Oliff  
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01 FC:1253

1020.00 OP

JAO:JXT/ldg  
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**DEPOSIT ACCOUNT USE  
AUTHORIZATION**  
Please grant any extension  
necessary for entry;  
Charge any fee due to our  
Deposit Account No. 15-0461